

PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

Complete Known 107523846

(use as many sheets as necessary)

Sheet

of

Application Number

Filing Date

First Named Inventor

BOYLE, Adrian

Group Art Unit

Examiner Name

Attorney Docket Number

[illegible][illegible]

**Examiner
Signature**

/Shamim Ahmed/ (02/12/2007)

Date Considered

02/12/2007

Please type a plus sign (+) inside this box →



PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0851-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

Substitute for form 1449/APTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

of

Application Number

Filing Date

First Named Inventor

Group Art Unit

Examiner Name

Attorney Docket Number

Complete if known **107523846**

BOYLE, Adrian

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SA		Patent Abstracts of Japan, vol. 009, no. 100 (M-376), 2 May 1985 & JP 59 225896 A (HANDOUTAI ENERUGII KENKYUSHO: KK), 18 December 1984	
SA		LIM P ET AL, "Laser-Assisted Liquid Film Etching", Applied Physics Letters, American Institute of Physics, New York, US, vol. 62, no.25, 21 June 1993, pages 3345-3347, XP000380997, ISSN: 0003-6951, page 3345	
SA		DATABASE WPI, Section Ch, Week 198637, Derwent Publications Ltd., London, GB: Class L03, AN 1986-240798 XP02261883 & JP 61 053731 A (ANRITSU ELECTRIC CO LTD), 17 March 1986, abstract; figure 1	
SA		SVORCIK V ET AL: "Laser-Stimulated Etching of N-Si in aqueous solutions" Material Letters, North Holland Publishing Company, Amsterdam, NL, vol.9, no.5/6, 1 March 1990, pages 204-206 XP000127337, ISSN: 0167-577X, the whole document	
SA		Patents Abstracts of Japan, vol. 012, no. 330 (E-655), 7 September 1988 & JP 63 094657 A (NEC CORP), 25 April 1988,	

Examiner
Signature

/Shamim Ahmed/ (02/12/2007)

Date
Considered

02/12/2007

¹ EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.² Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.